

Abstract Submitted  
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**Micro-optomechanical trampoline resonators**<sup>1</sup> BRIAN PEPPER, DUSTIN KLECKNER, UC Santa Barbara, PETRO SONIN, EVAN JEFFREY, University of Leiden, DIRK BOUWMEESTER, UC Santa Barbara, University of Leiden — Recently, micro-optomechanical devices have been proposed for implementation of experiments ranging from non-demolition measurements of phonon number to creation of macroscopic quantum superpositions. All have strenuous requirements on optical finesse, mechanical quality factor, and temperature. We present a set of devices composed of dielectric mirrors on Si<sub>3</sub>N<sub>4</sub> trampoline resonators. We describe the fabrication process and present data on finesse and quality factor.

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Brian Pepper  
UC Santa Barbara

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